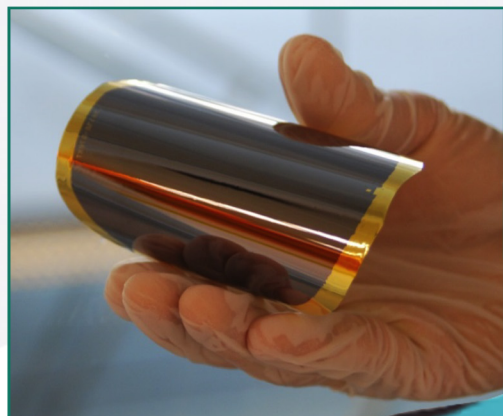


Lifted-off Thin-film Solar Cell

Reduce III-V solar cell cost by >40%

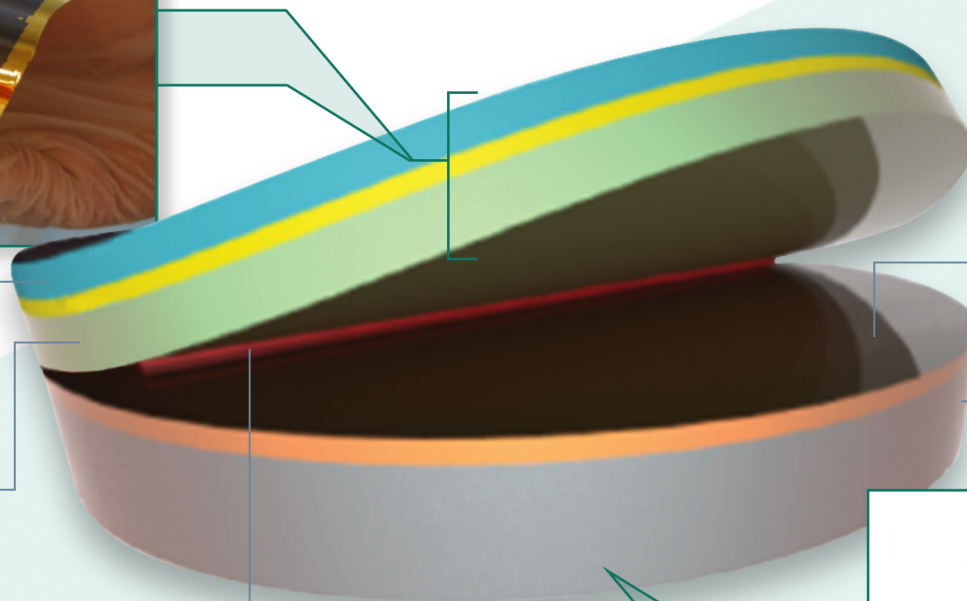
- Reuse the GaAs parent wafer in production
- Made possible through Non-Destructive Epitaxial Lift Off (ND-ELO)
- Faster, cheaper, reliable and reproducible



THIN FILM SUBSTRATE

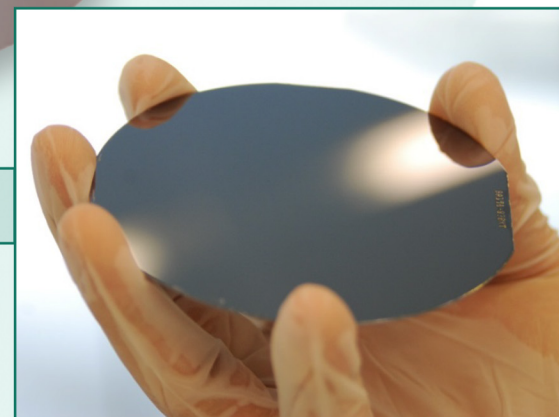
ACTIVE SOLAR REGION

SELECTIVE ETCHING
OF SACRIFICIAL LAYER



RE-USABLE WAFER SURFACE

PARENT WAFER



Cleaned Parent Wafer

For more information please contact :

Trina Chiara at (917) 975-1863

or chiarat@fiksucor.com